

OUT TO REACTOR (carrier gas + source gas)

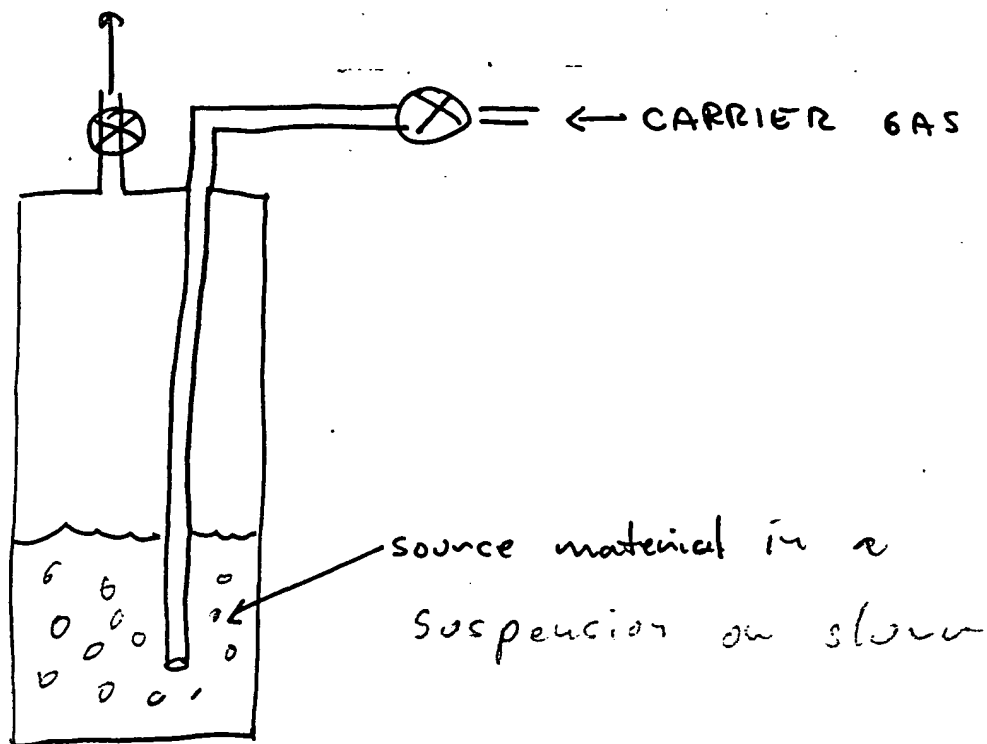


FIGURE 1

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2DP2

PLACE SUBSTRATE
IN REACTOR
WITH ATTACHED BUBBLER

EVACUATE REACTOR
& HEAT SUBSTRATE TO
REACTION TEMPERATURE

FLOW CARRIER GAS
THROUGH BUBBLER INTO
REACTION CHAMBER
TO EFFECT DEPOSITION

STOP CARRIER GAS FLOW
EVACUATE CHAMBER

COOL SUBSTRATE
TO ROOM TEMP

VENT REACTOR,
REMOVE FINISHED PART

FIGURE 2

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